

# Newsletter: Fall 2019

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# Swedish Center for III-Nitride Technology

Next Board Meeting 5 February, 2020 in Ericsson, Gothenburg

## **PROJECT UPDATES**

**Epitaxial growth development**: Thanks to the efforts of SweGaN, the new quartz-free reactor for growth of GaN -Gandalf is now operational. Transfer of growth process recipes from Solaris and growth optimization for N-polar epitaxy is under way. Structural arrangement and origin of polarity inversion in N-polar AIN is established. In a collaboration with Epiluvac a flow-modulation growth is implemented to minimize formation of structural defects.

**HEMT** technology: ON Semi, SweGaN, LiU and Chalmers are jointly exploring the voltage capability of SweGaN's Quanfine™-structure with improved leakage breakdown properties. Isolation implantation and optimization of dielectrics is underway. The maximum breakdown voltage is above 1800 V for an  $L_{\alpha d}$  of 50  $\mu m$ .



Vertical GaN power devices: Muhammad Nawaz (ABB & LiU) is appointed project leader. Material for GaN-on-SiC SBDs has been grown and processed for mesa diodes. Mg implantation for p-type doping of GaN has been performed and temperature profile for RTA being optimized. A new set-up for characterization of power devices up to 3 kV and 40 A (parameter-analyzer, probestation, and a black-box) has been installed at Chalmers.

GaN MMIC: The new design-kit needed for the in-house MMIC-process is finalized and a tape-out is planned for the beginning of 2020. The processing of the multi-layer circuits in BCB designed by Saab is being finalized and circuits will be delivered in January 2020. The strategy for aggressive gate scaling is revised to define 25-30 nm gate recesses in the SiN<sub>x</sub>-passivation layer using a single resist and dry-etch with CF<sub>4</sub>-plasma.



Developing next generation highpower β-Ga<sub>2</sub>O<sub>3</sub> material: LiU together with Epiluvac and SweGaN has built a unique hot-wall MOCVD reactor for growth of β-Ga<sub>2</sub>O<sub>3</sub>, and related alloys.

Education and outreach: We organized a study visit of the Graduate School Agora Materiae to the Motor lab, Collaborative robot lab and Digital High Voltage Lab at ABB on 28th of May.



The optical phonon mode order and the appearance of the reststrahlen bands for β-Ga<sub>2</sub>O<sub>3</sub> have been determined. The longitudinal-phonon-plasmon coupling in β-Ga<sub>2</sub>O<sub>3</sub> is established and it is found that the modes polarized in the monoclinic plane change their direction as a function of free electron concentration.

Philipp Kühne gave a lecture on the Challenges for Autonomous driving, High frequency Electronics and Renewable Energies at Pint of Science in May. Peter Raad (Southern Methodist University, USA) gave a minicourse on Computation Fluid Dynamics at LiU in June.

C3NiT Day with more than 60 participants from 7 countries was held on 12 November 2019

### RESEARCH HIGHLIGHTS

#### **Recent Publications**

T. Huang, S. An, J. Bergsten, S. He, and N. Rorsman, "A power detector based on GaN high-electron-mobility transistors for a gigabiton-off keying demodulator at 90 GHz", Ipn. J. Appl. Phys. 58, 3CSSD19, 2019.

A. Malmros, Jr-Tai Chen, H. Hjelmgren, J. Lu, L. Hultman, O. Kordina, E. Ö. Sveinbjörnsson, H. Zirath, and N. Rorsman, "Enhanced Mobility in InAIN/AIN/GaN HEMTs using a GaN interlayer", IEEE Transactions on Electron Devices, 66, 2910, 2019.

M. Schubert, A. Mock, R. Korlacki, S. Knight, Z. Galazka, G. Wagner, V. Wheeler, M. Tadjer, K. Goto, V. Darakchieva, "Longitudinal Phonon Plasmon Mode Coupling in β-Ga<sub>2</sub>O<sub>3</sub>", Appl. Phys. Lett. 114, 102102, 2019.

M. Schubert, A. Mock, R. Korlacki, V. Darakchieva, "Phonon Order and Reststrahlen Bands of Polar Vibrations in Crystals with Monoclinic Symmetry", Phys. Rev. B 99, 041201, 2019.

A. Mock, R. Korlacki, S. Knight, M. Stokey, A. Fritz, V. Darakchieva, and M. Schubert, "Lattice dynamics of orthorhombic NdGaO<sub>3</sub>" Phys. Rev. B 99, 184302 (2019).

PhD Thesis: Anna Malmros – "Advanced III-Nitride Technology for mm-Wave Applications", Chalmers, 10th of June 2019



















